IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ın re P	atent A	ppiica	ITION OT:	
Hyun-l	Kwan C	hung	et al.	
Applic	ation No	o.:		Group Art Unit:
Filed:	March	30, 20	004	Examiner:
For:	CONF	IGUR		TAINING ENHANCED AV(ENAV) BUFFER DDUCING METHOD THEREOF AND
			INFORMATION DISCLOS	SURE STATEMENT
PO Bo Alexar	nissione ox 1450 ndria, V		Patents 13-1450	
Sir:				
subjec	ed certa t U.S. p	ain info atent	ormation that the Examiner may	ovisions of 37 CFR § 1.56, there is hereby consider material to the examination of the the Examiner make this information of record bject application.
	1.	Encl	osures accompanying this Inform	nation Disclosure Statement are:
	1b. 1c. 1d.		application or a PCT Internatio English language translation (c each non-English language pu Explanations of Relevancy of F	complete or relevant portion(s)) attached to blication. References (ATTACHMENT 1(e), hereto) for of each non-English publication.
	2.	In a und	ccordance with 37 CFR § 1.98, erstood to be the relevance of e	a concise explanation of what is presently each non-English language publication is
	2a.		enclosed "English-language ve indicates the degree of relevan 609, Minimum Requirements for	s 2a, 2b, 2c and/or 2d) sh language publications were cited on the ersion of the search report or action which are found by the foreign office". (See MPEP or an Information Disclosure Statement, Part relevance, pp. 600-100 to 600-101, Rev. 1,

	2b. 📋	set forth in the application	1•			
	2c. satisfied because an English language translation (complete or reportion(s)) is attached to each non-English language publication					
	2d. enclosed as Attachment 1(e), hereto.					
3. No admission is made that the information cited in this Statement is, or is considered to be, material to patentability nor a representation that a search has been made (other than search report(s) from a counterpart foreign application or a PCT International Search Report, if submitted herewith). 37 CFR §§ 1.97(g) and (h).						
				Respectfully submitted,		
				STAAS & HALSEY LLP		
Washingt Telephon	3/30 v York Ave on, D.C. : e: (202) 43 : (202) 43	e., Ň.W., Suite 700 20005 34-1500	Ву:	Michael D. Stein Registration No. 37,240		

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	ATTORNEY DOCKET NO.	APPLICATION NO.	
	1793.1239		
LIST OF COPENDING APPLICATIONS	FIRST NAMED INVENTOR		
	Hyun-Kwan Chung et al.		
	FILING DATE	GROUP ART UNIT	
	March 30, 2004		

The following, prior-filed, copending U.S. patent application(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application. Pursuant to 37 CFR 1.98(a)(2)(iii), a copy of the identified copending application(s) is provided.

It is requested that the Examiner acknowledge his consideration of application(s) below-listed by initialling same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

U.S. PATENT APPLICATION DOCUMENTS

*EXAMINER					
INITIAL		U.S. SERIAL NO.	FILING DATE	NAME	ASSIGNEE
	1	10/647,445	August 26, 2003	Jung et al.	Samsung Electronics Co., Ltd.
	2	10/165,427 (Published as 2003/0012558)	June 10, 2002	Kim et al.	Samsung Electronics Co., Ltd.
	3	10/170,419 (Published as 2003/0049017)	June 14, 2003	Chung et el	Samsung Electronics Co., Ltd.
	4	10/277,094 (Published as 2003/0084460)	October 22, 2002	Chung et al	Samsung Electronics Co., Ltd.
	5				
	6				
	7				
	8				

EXAMINER	DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through				
citation if not in conformance and not considered. Include copy of this form with next communication to applicant.				